

APR 23 2004

OFFICIAL

Attorney Docket No. A-68359-1/RMA/JML
Dorsey File No. 469113-41

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

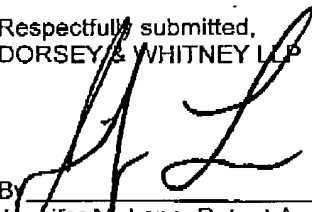
In re application of: Gerard S. MALONEY et al.	Examiner: TBD
Serial No.: 10/027,935	Group Art Unit: 3724
Filing Date: December 21, 2003	<u>CERTIFICATE OF FAX TRANSMISSION</u>
For: Apparatus and Method for Chemical-Mechanical Polishing (CMP) Head Having Direct Pneumatic Wafer Polishing Pressure	I hereby certify that this correspondence is being transmitted by facsimile transmission to fax # 703 872 9306 on April 23, 2004.
	Signed <u>Joyce Abriam</u> Joyce Abriam

STATUS REQUEST

Technology Center 3700
Group Art Unit 3706
U.S. Patent Office Central Facsimile Number 703-872-9306

Sir:

Please provide the status of the above application as soon as possible:

Respectfully submitted,
DORSEY & WHITNEY LLP
By Jennifer M. Lane, Patent Agent, Reg. No. 51,916
R. Michael Ananian, Reg. No. 35,050
Attorney for ApplicantFour Embarcadero Center - Suite 3400
San Francisco, California 94111-4187
Tel.: (415) 781-1989
Fax: (415) 398-3249
SF-1141558